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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known	
Application Number	10/717,963
Filing Date	11/21/2003
First Named Inventor	SUMIO ASHIDA
Art Unit	2655 1256
Examiner Name	Unknown <i>Argent</i>
Attorney Docket Number	008312-0306969

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Foreign Patent Document Country Code ³ , Number ⁴ , Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
<i>[initials]</i>		JP 2003-233931	08/2003	Kojima et al.	

EXAMINER Signature  **Date Considered** 4/21/06
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FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office		Atty. Dkt. No.	M#	Client Ref.					
			008312-0306969	T7KO-03S1080					
INFORMATION DISCLOSURE STATEMENT BY APPLICANT									
Date: April 29, 2005		P age e 1	of 1						
Applicant: ASHIDA et al.									
Appn. No.: 10/717,963									
Filing Date: November 21, 2003									
Examiner: Unassigned <i>by email</i>		Group Art Unit: 2665 <i>1756</i>							
U.S. PATENT DOCUMENTS									
Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)		Class	Sub Class	Filing Date (if appropriate)		
AR									
BR									
CR									
DR									
ER									
FR									
GR									
HR									
IR									
JR									
KR									
LR									
MR									
NR									
FOREIGN PATENT DOCUMENTS					English Abstract	Translation Readily Available			
	Document Number	Date MM/YY YY	Country	Inventor Name		Enclosed	No	Enclose	No
OR	JP 2001-167475 A	06/2001	Japan	NONAKA et al.		x			
PR	JP 2001-126308 A	05/2001	Japan	ARAI et al.		x			
QR	JP 11-339314 A	12/1999	Japan	NAGINO et al.		x			
RR	JP 03-125343 A	05/1991	Japan	SUZUKI et al.		x			
SR	JP 10-116441 A	05/1998	Japan	ROSEN et al.		x			
TR	JP 2000-339760 A	12/2000	Japan	KUSADA et al.		x			
UR	JP 2001-014723 A	01/2001	Japan	HIROTUNE et al.		x			
VR	JP 2002-298433 A	10/2002	Japan	YUZUSU et al.		x			
WR						x			
XR									
OTHER (including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)									
YR	Japanese Office Action dated March 29, 2005 for Appln. No. 2002-339437								
ZR	Japanese Office Action dated March 29, 2005 for Appln. No. 2002-342896								
AAR									
BBR									
Examiner					Date Considered:	4/21/06			
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FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office					Atty. Dkt. No.	M#	Client Ref.		
						0306969	T7KO-03S1080		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT									
Date: November 21, 2003		Page 1 of 1	Applicant: SUMIO ASHIDA et al.						
			Appln. No.: UNASSIGNED						
			Filing Date: November 21, 2003			11/21/03			
			Examiner: UNKNOWN			Group Art Unit: UNKNOWN			
U.S. PATENT DOCUMENTS									
Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)		Class	Sub Class	Filing Date (if appropriate)		
AR									
BR									
CR									
DR									
ER									
FR									
GR									
HR									
IR									
	Document Number	Date MM/YYYY	Country	Inventor Name		Enclosed	No	Endose	No
UR	JR 2003-67974	03/2003	Japan	Inao et al.		X			X
UR	KR 2000-322770	11/2000	Japan	Osada et al.		X			X
UR	LR 2001-232941	08/2001	Japan	Ashida et al.		X			X
UR	MR 11-213446	08/1999	Japan	Ota et al.		X			X
UR	NR 2000-222777	08/2000	Japan	Uno et al.		X			X
UR	OR 2002-279693	09/2002	Japan	Miyamoto et al.		X			X
UR	PR 2003-233931	08/2003	Japan		<i>of b. b.</i>	X			X
	QR				<i>b</i>				
	RR								
	SR								
OTHER (Including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)									
UR	TR	T. Inase et al., "Investigation of Protective Layer for High Transfer Rate Phase Change Optical Disk," Tokyo Research Lab., Tosoh Corp., pages 37-42 (12/2001)							
UR	UR	Mayumi Uno et al., "Acceleration of crystallization process by nitride interface layer," Optical Disk Systems Development Center, Matsushita Electric Industrial Co., Ltd., pages 85-90 (11/1992)							
UR	VR	Rie Kojima et al., "Ge-Sn-Sb-Te Phase-change Recording Material Having High Crystallization Speed," Optical Disk Systems Development Center, Matsushita Electric Industrial Co., Ltd., pages 36-41 (11-12/2000)							
UR	WR	Michiaki Shinotsuka et al., "High-speed Blue-laser Recording on the Double-decker Phase Change Disk with High-Reliability," Research and Development Group, Ricoh Company, Ltd., IEEE 2002, pages 234-236 (2002)							
	XR								
	YR								
Examiner <i>Sumio Ashida</i>					Date Considered: <i>11/21/03</i>				
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.									